

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): PYO, Sung Gyu et al.

Application No.:

Group:

Filed: May 30, 2002

Examiner:

For: CU FILM DEPOSITION EQUIPMENT OF SEMICONDUCTOR DEVICE

L E T T E R

Assistant Commissioner for Patents
Box Patent Application
Washington, D.C. 20231

May 30, 2002
0465-0865P-SP

COPY

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
REPUBLIC OF KOREA	P 2001-32907	06/12/01

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

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By: _____

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PYU, Sung Hui et al.
Mar. 30, 2002
ES&B-103/205-8002
Docket No. 0465-0865F
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대한민국 특허청

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This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원번호 :
Application Number

특허출원 2001년 제 32907 호

출원년월일 :
Date of Application

2001년 06월 12일

출원인 :
Applicant(s)

주식회사 하이닉스반도체



2001 06 19
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특 허 청

COMMISSIONER

